

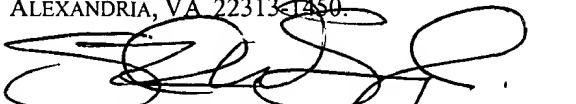


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**PATENT**  
Atty Docket No. KLAC0012

I HEREBY CERTIFY THAT ON JULY 28, 2003, THIS  
CORRESPONDENCE IS BEING DEPOSITED WITH THE  
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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

CHRISTOPHER FAIRLEY, ET AL.

Title: CONFOCAL WAFER INSPECTION  
METHOD AND APPARATUS

Serial No.: 09/533,203

Filed: MARCH 23, 2000

Group Art Unit: 2878

Examiner: Eric J. Spears

**RESPONSE TO OFFICE ACTION**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated March 26, 2003, please enter the following  
amendments and consider the following remarks in connection with the above-identified  
patent application.